

Electronic Patent Application Fee Transmittal

Application Number:	10060204			
Filing Date:	24-Sep-2002			
Title of Invention:	VACUUM PROCESSING APPARATUS WITH WAFERS, SUBTRATES AND/OR SEIMICONDUCTORS			
First Named Inventor/Applicant Name:	Shigekazu Kato			
Filer:	William Ivan Solomon/Kelli Harris			
Attorney Docket Number:	520.30414R49			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	120	120

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				120